

Title	The high frequency electrical properties of interconnects on a flexible polyimide substrate including the effects of humidity
Author(s)	McGibney, Eoin; Barton, John; Floyd, Liam; Tassie, Paul; Barrett, John
Publication date	2011-01
Original citation	McGibney, E.; Barton, J.; Floyd, L.; Tassie, P.; Barrett, J (2011) 'The High Frequency Electrical Properties of Interconnects on a Flexible Polyimide Substrate Including the Effects of Humidity'. IEEE Transactions on Components, Packaging and Manufacturing Technology, 1 (1):4-15. doi: 10.1109/TCPMT.2010.2100731
Type of publication	Article (peer-reviewed)
Link to publisher's version	http://ieeexplore.ieee.org/stamp/stamp.jsp?tp=&arnumber=5734805&isnnumber=5738414 http://dx.doi.org/10.1109/TCPMT.2010.2100731 Access to the full text of the published version may require a subscription.
Rights	© 2011 IEEE. Personal use of this material is permitted. Permission from IEEE must be obtained for all other uses, in any current or future media, including reprinting/republishing this material for advertising or promotional purposes, creating new collective works, for resale or redistribution to servers or lists, or reuse of any copyrighted component of this work in other works.
Item downloaded from	http://hdl.handle.net/10468/422

Downloaded on 2017-02-12T08:29:09Z



UCC

Coláiste na hOllscoile Corcaigh, Éire
University College Cork, Ireland



Cork Open Research Archive
Cartlann Taighde Oscailte Chorcaí

McGibney, E.; Barton, J.; Floyd, L.; Tassie, P.; Barrett, J.; , "The High Frequency Electrical Properties of Interconnects on a Flexible Polyimide Substrate Including the Effects of Humidity," *Components, Packaging and Manufacturing Technology, IEEE Transactions on* , vol.1, no.1, pp.4-15, Jan. 2011

doi: 10.1109/TCPMT.2010.2100731

<http://ieeexplore.ieee.org/stamp/stamp.jsp?tp=&arnumber=5734805&isnumber=5738414>

© 2011 IEEE. Personal use of this material is permitted. Permission from IEEE must be obtained for all other uses, in any current or future media, including reprinting/republishing this material for advertising or promotional purposes, creating new collective works, for resale or redistribution to servers or lists, or reuse of any copyrighted component of this work in other works.

CORA Cork Open Research Archive <http://cora.ucc.ie>

The High Frequency Electrical Properties of Interconnects on a Flexible Polyimide Substrate Including the Effects of Humidity

Eoin McGibney, John Barrett, John Barton, Liam Floyd, and Paul Tassie

Abstract—Flexible circuit board materials can be used to advantage in radio frequency and high-speed digital systems but an obstacle to their use is the lack of availability of information on the electrical properties of materials to high frequencies and, in particular, the variation in dielectric constant and loss tangent as a function of frequency. This makes accurate electromagnetic simulation of high frequency flexible interconnects difficult. The variation of the electrical properties of these materials as a function of environmental parameters, such as humidity, is also unknown at higher frequencies. This paper has, using microwave resonators, investigated the electrical properties from 2 GHz to 18 GHz of a polyimide flexible circuit board material saturated at 25% RH and at 85% RH relative humidity levels. Rigid circuit board materials FR4 and CER-10 were also measured as reference materials. The relative permittivity, ϵ_r , total loss, α_T , and loss tangent, $\tan \delta$, have been extracted from the measurements for each material. The strong influence of conductor losses on overall losses when using thin materials such as flex at high frequency has also been evaluated and quantified in these measurements. In addition to the resonators used for measurement of material electrical properties, microstrip transmission lines were also included on each test sample and their s-parameters were measured at the same time and under the same conditions as the resonators. Comparisons between the measured electrical performance of the microstrip transmission lines and simulations of the lines based on the extracted material parameters show a high degree of correlation, indicating the validity of both the use of the resonator approach and overall loss measurement methodologies.

Index Terms—Electrical characterization, flexible substrates, high frequency, material properties.

I. INTRODUCTION

THE USE OF printed circuit boards (PCBs) for high frequency applications, either radio frequency (RF) or high-speed digital, requires a detailed description of the frequency-dependent dielectric properties, dielectric constant

Manuscript received April 1, 2009; revised March 8, 2010; accepted April 5, 2010. This work was supported by the SFI-Funded National Access Program (NAP-72), and by PRTL Strand 3 under the M-Zones Project. Recommended for publication by Associate Editor J. J. Liu upon evaluation of reviewers' comments.

E. McGibney is with the Digital Video Product Group, Analog Devices, Limerick, Ireland (e-mail: eoin.mcgebney@analog.com).

J. Barrett is with the Cork Institute of Technology (CIT), Bishopstown, Cork, Ireland (e-mail: john.barrett@cit.ie).

J. Barton is with the Tyndall National Institute, Cork, Ireland (e-mail: john.barton@tyndall.ie).

Color versions of one or more of the figures in this paper are available online at <http://ieeexplore.ieee.org>.

Digital Object Identifier 10.1109/TCAPT.2010.2055158

and loss tangent, and of conductor losses so that overall losses and dispersion can be modeled using an EM simulator. It is critical for simulation accuracy that the simulation input information includes the electrical characteristics of the interconnect material(s) across all of the application bandwidth [1] and, where relevant, the variation of these properties with ambient environmental parameters such as temperature and humidity. Having this information available can allow the use of lower cost conventional PCB dielectric materials even to high frequencies [2]. While new materials are constantly emerging for both packages and circuit boards, relatively little has been published on the effect of environmental parameters, particularly moisture, on the high frequency electrical properties of even long established interconnect materials. This problem is greater for newer materials. Moulding compounds, encapsulants, underfills and PCB dielectrics all strongly influence the high frequency electrical performance of interconnects but we lack information on electrical properties, particularly dielectric constant and loss tangent, over wide bandwidths as a function of moisture content. The reliability of electrical simulations for interconnects fabricated from these materials and subject to electrical property changes on absorbing moisture is therefore open to question. An example of this is to be found in [3], where a flexible antenna for outdoor use showed significant change in electrical properties on absorption of moisture. There is also a growing use, for cost saving, of materials that were not necessarily originally intended for use at higher frequencies. Flexible substrates such as polyimide are being commonly used to increase system level integration in laptop computers, mobile phones, and connector systems and they are seeing growing use in RF applications for the purposes of increasing component density, miniaturization and conforming to awkwardly shaped spaces [4], [5]. The mechanical characteristics of flexible substrates make them attractive for these applications but very little information has been published describing their overall high frequency electrical characteristics, including both conductor and dielectric performance, or the effect of dielectric moisture absorption on microstrip configurations.

Therefore, the work described in this paper was undertaken to:

- 1) identify appropriate test structures and procedures for measurement of the high frequency electrical properties

of copper interconnects on a flexible PCB dielectric and the dielectric properties for the flex material;

- 2) extract conductor losses, dielectric constant, and loss tangent data up to 18 GHz from the measured s-parameter data;
- 3) examine the variation in the dielectric properties of materials after absorption of moisture;
- 4) compare the electrical properties of the flexible material with those of two common rigid PCB dielectrics;
- 5) verify the measurement and extraction methodologies by comparing measured and EM model results of microstrip validation structures.

The results in this paper present the characterization of copper interconnects fabricated on a flexible PCB over a 2 GHz to 18 GHz bandwidth; the separation of the different contributions of conductor and dielectric losses to overall losses as a function of frequency and moisture absorption; and cross-verification using microstrip interconnects representative of the “as manufactured” interconnects that would be used on a high-frequency PCB. Additionally, practical issues such as high frequency probing and measurement on double sided flexible substrates using via-less launches are discussed.

II. RELATED WORK

The emphasis in this paper is on “overall” loss characterization, including conductor and dielectric losses, as it is this overall loss that is most relevant to design of real interconnects. The selection of test structures therefore focused on structures that could be used for extraction of total losses. Resonators are frequently applied for the study of microstrip dispersion and material properties [6], [7] and are suitable for the measurement of microstrip quality factor (Q-factor) or total loss. Examples of recent research published in this field [7]–[9] demonstrate the application of resonator approaches for the determination of relative permittivity and loss tangent of rigid PCB materials. In these studies, ring resonator, T-junction ($\lambda/4$ wave), and line resonator structures were used to determine the material properties of FR4, BT, and liquid crystal polymer (LCP) substrates. In addition to the study of the high frequency characteristics of materials, the change in material properties with temperature for an FR4 type substrate has also been reported in [9]. This paper [9] evaluated the change in both material properties with both humidity and temperature. When using resonators for dielectric characterization, conductor loss is usually a discarded by-product of the extraction of dielectric properties from overall loss measurements; in this paper they are retained to present a complete picture of overall interconnect losses and of the relative impact of each component of loss on overall loss.

III. GENERAL APPROACH

The electrical quantities to be experimentally measured and modeled over the measured frequency band are conductor loss, relative permittivity, ϵ_r and the loss tangent, $\tan \delta$. A two-port microstrip resonator approach was implemented to

characterize the flexible substrate. The results of a two-port s-parameter measurement of each resonator structure facilitated the extraction of the three desired electrical properties. The relative permittivity was determined by the relationship between the physical length of the resonator and the measured resonant frequency, f_{res} . Subtracting conductor loss, α_C , from the measured total loss, α_T , determined dielectric loss and allowed calculation of the loss tangent. The flexible substrate material characterized was Sheldahl NovaClad [10]. Two rigid PCB dielectrics, FR4 (a very widely used low to moderate frequency substrate) and Taconic CER-10 [11] (a commonly used high frequency composite substrate), were also included in the tests both for comparison purposes and also to verify the general applicability of the measurement and extraction methodologies. All substrates were double-sided PCBs, consisting of a copper ground plane and a single signal layer. These materials were characterized using the same resonator methods as the flexible substrate.

While dielectric constant can be isolated from the measured resonator resonant frequency, f_{res} , relatively straightforwardly, the calculation of dielectric loss from total resonator loss measurement requires the separation of both conductor and radiation losses from the total loss. This approach relies on the use of empirical equations to approximate these losses. The calculation of both losses using these equations is sensitive to uncertainties in fabricated geometry, in particular substrate height, conductor thickness, and surface roughness. Knowledge of the post-fabrication resonator physical length is also required to accurately determine the effective permittivity, ϵ_{eff} , from the measured f_{res} . Post test sample fabrication metrology of x , y , and z -dimensions was therefore performed to identify deviations from design dimensions. These measurements also included measurement of conductor surface roughness. The expressions used for the calculation of the conductor and radiation loss were chosen from the literature [12]–[14], were implemented using C-code and used to automatically generate a file describing all loss and dispersion parameters across the measured frequency range for each of the samples. Extensive empirical studies [15]–[17] have published expressions for the prediction of the effective dielectric permittivity of substrates and of microstrip dispersion. These equations have previously been evaluated by York in [18] and, based on these findings, the equations presented by Kobayshi [15] were used in this paper. A comparison between empirical equations and measured results is included in Section VII.

A. Extraction of $\epsilon_r(f)$ from $\epsilon_{eff}(f)$

The resonant frequencies of the resonators were estimated during the design phase using the equations given in [17]. The measured resonant frequency and the resonator length of the fabricated resonators were used to calculate the effective relative permittivity, $\epsilon_{eff}(f)$, of the substrate materials across the measurement bandwidth. The relative permittivity of each substrate material was calculated using (1)–(3) as presented in [7]. These equations use the geometry of the substrate and observed $\epsilon_{eff}(f)$ to calculate $\epsilon_r(f)$

$$\epsilon_r(f) = \frac{2\epsilon_{eff}(f) + M - 1}{M + 1} \quad (1)$$

$$M = \left(\frac{1 + 12h}{w_{\text{eff}}} \right)^2 \quad (2)$$

$$w_{\text{eff}} = w + (1.25t/\pi) [1 + \ln(2h/t)] \quad (3)$$

188 where h is the substrate height, w is the microstrip line width,
189 w_{eff} is the calculated effective microstrip width, and t is the
190 microstrip line thickness.

191 B. Extraction of Dielectric Loss

192 The total loss (α_T) was determined from the measured Q-
193 factor of each resonator. The total loss has three components:
194 the conductor loss (α_c), the dielectric loss (α_d), and radiation
195 losses (α_r). Applying (4)–(6) to the measured data yielded the
196 total loss. Empirical expressions [12]–[14], [19] were used to
197 approximate the conductor and radiated loss of the microstrip
198 line on each substrate

$$\alpha_T = \alpha_c + \alpha_d + \alpha_r$$

$$\alpha_T(Np/m) = \frac{\pi}{Q_0 \lambda_g} \quad (4)$$

$$Q_L = \frac{f_{\text{res}}}{BW_{-3\text{dB}}} \quad (5)$$

$$Q_0 = \frac{Q_L}{1 - 10^{(-IL/20)}}$$

199 where Q_L and Q_0 are the loaded and unloaded Q-factors, IL
200 is the measured insertion loss at resonance, $BW_{-3\text{dB}}$ is the
201 -3dB bandwidth of the resonant peak and λ_g is the guide
202 wavelength.

203 Isolating the dielectric loss from the measured total loss
204 allowed $\tan\delta$, the loss tangent, to be calculated, $\tan\delta$ is
205 extracted from the dielectric loss by [7]

$$\tan\delta = \frac{\alpha_d \lambda_0}{27.3} \cdot \frac{(\epsilon_r - 1) \sqrt{\epsilon_{\text{eff}}}}{\epsilon_r (\epsilon_{\text{eff}} - 1)} \quad (6)$$

206 C. Environmental Effects Setup

207 To evaluate the influence of moisture absorption on the
208 electrical properties of each substrate the experimental mea-
209 surements were repeated after the materials have been exposed
210 to moisture. Previous research in the area of moisture diffusion
211 in PCB substrate materials was used to select the moisture
212 soak conditions [20]. Moisture absorption in polymer materials
213 generally obeys Fick's law, thereby defining the relationship
214 between the moisture absorption ratio, M , exposure time, t ,
215 and thickness of the material, d , as the relationship given by

$$M \propto \frac{\sqrt{t}}{d} \quad (7)$$

216 Data presented in [20] shows that a polyimide film of
217 thickness $125\ \mu\text{m}$ begins to saturate after moisture ratio of
218 greater than 200 (625 min) is reached. Therefore, Sheldahl
219 samples (thickness of $\sim 50\ \mu\text{m}$) were exposed to 85/85 relative
220 humidity conditions for a period of 24 h (1440 min). It was
221 envisaged that this period would ensure that the material would
222 be sufficiently saturated. A saturated condition was preferred
223 as it is the worst-case scenario for the effect of humidity on
224 the flexible substrate. Both rigid dielectrics were exposed to
225 the same relative humidity conditions but for a 48 h period.

TABLE I

DESIGN PARAMETERS FOR EACH SUBSTRATE, RELATIVE PERMITTIVITY,
AND LOSS TANGENT FIGURES ARE TYPICAL VALUES FROM
MANUFACTURERS' DATASHEETS

Substrate	ϵ_r	$\tan\delta$	Substrate Thickness	Line Width ($Z_0 \approx 50\ \Omega$)	Cu Thickness
Sheldahl	3.3	0.011	$48\ \mu\text{m}$	$100\ \mu\text{m}$	$10.2\ \mu\text{m}$
Taconic CER10	9.5 ± 0.5	0.0035	$583.51\ \mu\text{m}$	0.635 mm	$48.8\ \mu\text{m}$
FR4	4.4	0.0017	$1491.75\ \mu\text{m}$	1.6 mm	$35\ \mu\text{m}$

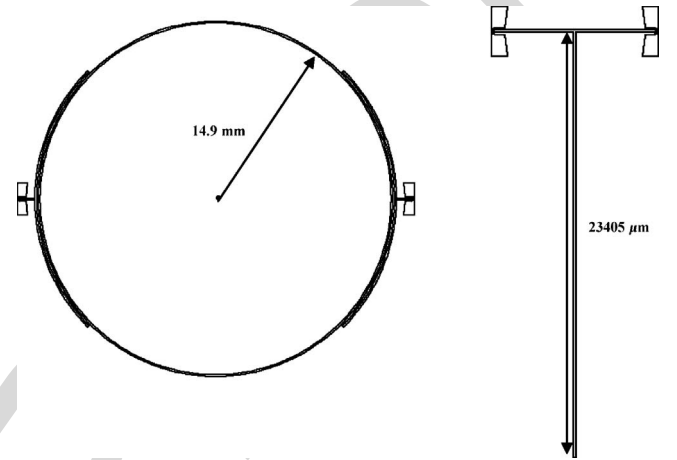


Fig. 1. 2 GHz microstrip ring resonator and quarter wave resonators on Sheldahl substrate.

IV. RESONATOR STRUCTURES

226 Microstrip ring and quarter-wave PCB resonator structures
227 were designed and fabricated on each of the test substrates.
228 The principal parameter relevant in determining the funda-
229 mental resonant frequency, f_0 , of the resonator is the physical
230 length, l_{res} ; in the case of the ring resonator it is the mean
231 radius, r_m . By varying l_{res} and r_m , the f_0 of each individual
232 resonator was chosen at various frequency points from 1 GHz–
233 12 GHz. Multiples of these frequencies also resonate at nf_0
234 where $n = 1, 2, 3, \dots$, thereby covering the 2 GHz–20 GHz
235 measurement frequency range. The physical material speci-
236 fications and design parameters of each substrate material are
237 summarized in Table I. These parameters are manufacturers'
238 typical specifications and results of the post fabrication dimen-
239 sional measurements. These parameters were used to calculate
240 the static characteristic impedance, static effective permittivity
241 $\epsilon_{\text{eff}}(0)$, and guide wavelength λ_g .
242

243 An example of each resonant structure is given in Fig. 1; in
244 each case the annotated dimensions are the calculated values
245 for a 2 GHz resonator structure fabricated on the Sheldahl
246 substrate. Where used, edge-coupling gaps were chosen to
247 lightly couple energy to each resonator and the gaps are
248 typically twice the line widths. Coupling gaps of this width
249 result in an S_{21} of approximately -30 dB to -40 dB at
250 resonance. This level of coupled energy ensured the resonators
251 did not become loaded during measurements.

252 Relating the physical length of each resonator to the electri-
253 cal wavelength, the physical dimensions for each structure at a

particular resonant frequency can be determined (more detailed design procedures than can be presented here are available in [6], [17], and [21]). Equations (8)–(10) were used and the effective permittivity was calculated using the Kobayashi approximations

$$\lambda_g = \frac{c}{f\sqrt{\epsilon_{eff}}} \quad (8)$$

$$l_{res} = n\lambda_g \quad (9)$$

$$r_m = \frac{n\lambda_g}{2\pi} \quad (10)$$

where c is the speed of light in a vacuum = 2.99×10^8 m/s.

V. CPW LAUNCHES

Measurements on FR4 and CER10 substrates, being rigid, can be carried out using edge mount SMA connectors; due to the thinness ($\sim 50 \mu\text{m}$) of the flexible substrate, this approach was not feasible without special fixturing. Therefore, high frequency coplanar (CPW) probes were used for the measurement of each of the substrates. The Gnd-Signal-Gnd configuration of the CPW probes required the design of a coplanar-to-microstrip transition. Typically, this is achieved through placement of adjacent ground pads either side of the signal line with plated via holes to a ground plane underneath forming the ground connection to each launch ground pad [22]. However, vias could not be fabricated in the double-sided flexible material process used in this paper. To overcome this problem, via-less coplanar probe-to-microstrip transitions were incorporated in the resonator designs. To facilitate high frequency measurements, the CPW launches need to exhibit good wideband performance. From a literature search, two suitable launch structures were found [23], [24]. Each of these structures has demonstrated wideband measurement capability on wafer level structures and neither requires vias. The suggested design equations presented in [23] and [24], combined with EM simulation, were used to obtain the final dimensions of both launches. The radial stub launch illustrated in Fig. 2, previously reported by Williams [23], demonstrated wideband performance for the measuring of s-parameters of MMICs using coplanar probes. The radial stub provides low impedance between the ground plane of the substrate and the ground pad of the coplanar probe. The 180° radial pattern is required for wideband performance. The length of the outer stub radius, l , is approximated from

$$l \approx \lambda_0 / (2\pi\sqrt{\epsilon_r}). \quad (11)$$

The impedance of the stub is lowest when the stub radius equals l and this is considered as the optimum stub. Using (11) as an initial condition a full wave EM simulation was used to tune the physical dimensions of the stub to yield an impedance minimum at 10 GHz. This is approximately the center frequency of the measurement bandwidth.

A second via-less CPW-to-microstrip transition was also implemented, shown in Fig. 3; this transition was designed using recommendations outlined by Zheng [24]. This transition is more compact than the radial stub and is more easily

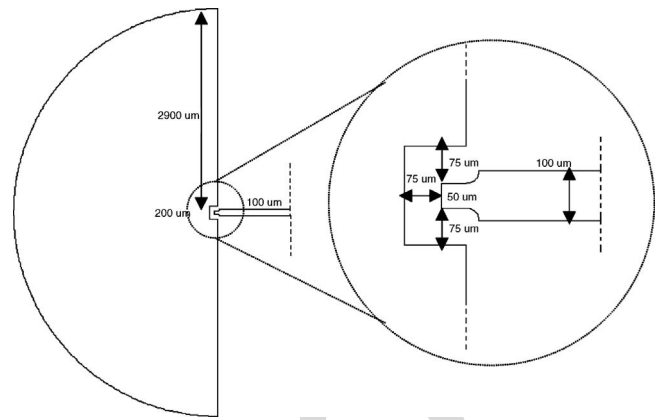


Fig. 2. Radial stub coplanar to microstrip launch.

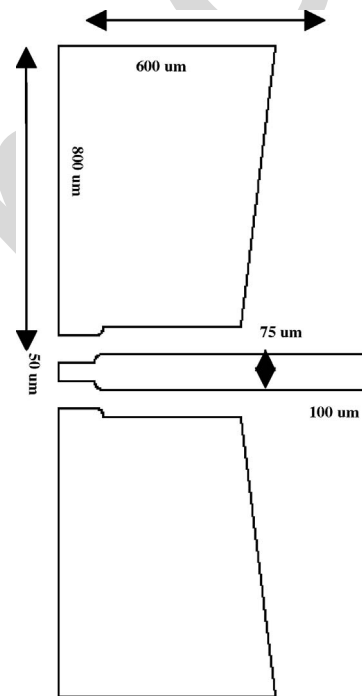


Fig. 3. Coplanar to microstrip transition.

fabricated. The transition is composed of a CPW section for placement of the measurement probes and a transition section where the CPW mode is transformed to a quasi-static TEM mode propagating on a microstrip line. This is physically done using a controlled taper between the signal lines and adjacent ground planes. On the flexible substrate, only a slight taper was required as the designed microstrip line width ($\sim 100 \mu\text{m}$) was comparable to the coplanar signal line width. For the measurements on the rigid boards more conventional CPW to microstrip launches were used. The design of the CPW launches for the rigid boards followed the layout guidelines recommended by [22]. A photograph of all of the resonant structures fabricated on the flexible substrate is shown in Fig. 4.

VI. MEASUREMENTS

S-parameter measurements were performed using an Agilent 8720D vector network analyzer with a frequency sweep

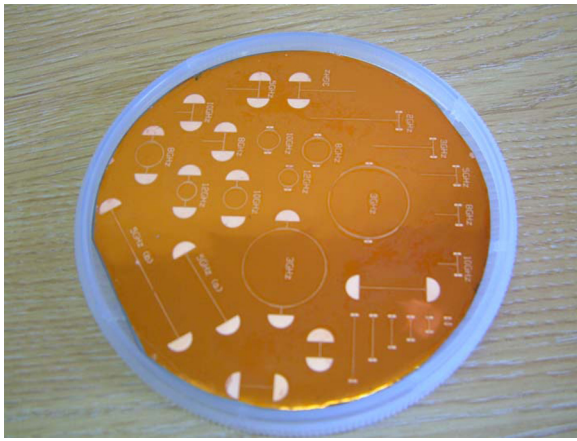


Fig. 4. Photograph of the fabricated structures on the flexible PCB (the flex-PCB is silicon wafer shaped because a former wafer mask aligner is used for photolithography).

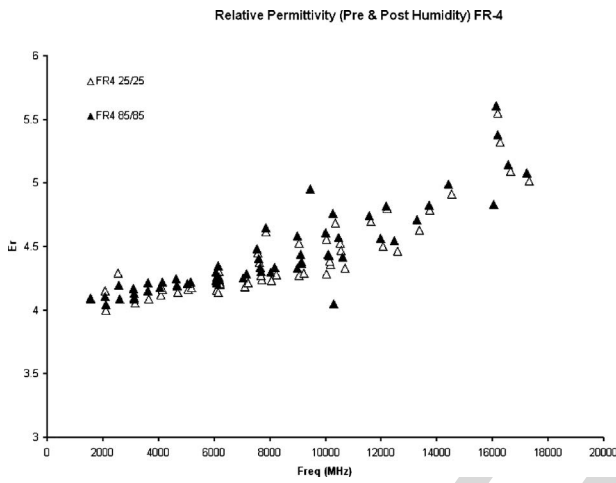


Fig. 5. Experimentally determined relative permittivity of FR4.

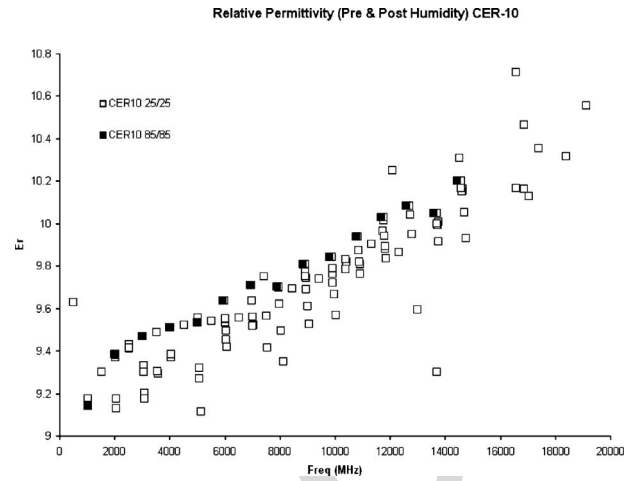


Fig. 6. Experimental determined relative permittivity of Taconic CER-10.

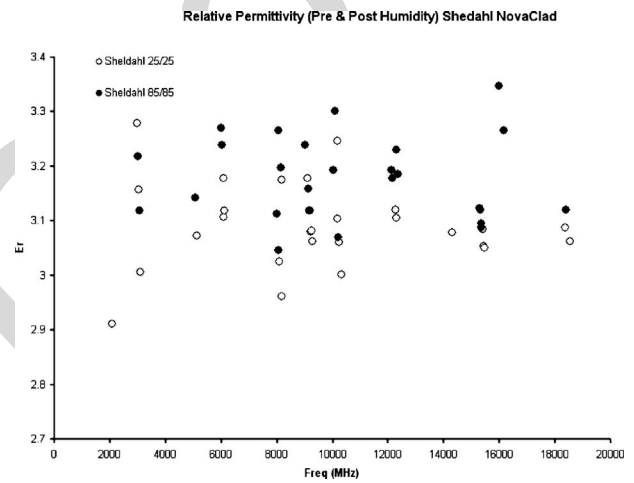


Fig. 7. Experimentally determined relative permittivity of Sheldahl NovaClad.

317 from 50 MHz to 20 GHz and 801 sampling points, giving
 318 a raw frequency step size resolution of 24.904 MHz. All
 319 structures were measured using CPW probes with full two-
 320 port calibration applied to the ends of the probe tips using a
 321 TRL calibration method. The cascade Microtech impedance
 322 standard substrate was used to verify the calibration accuracy.
 323 Measurement files were captured for each individual structure
 324 and later post processed into Touchstone (.s2p) format and im-
 325 ported into an RF circuit simulator for analysis and parameter
 326 extraction.

VII. RESULTS

A. Relative Permittivity

327
 328
 329 The measured s-parameters were imported into an RF circuit
 330 simulator as two-port s-parameter networks [25]. A frequency
 331 plot of the experimental s-parameter data for each structure
 332 was used to identify the resonant frequency, insertion loss and
 333 the -3 dB bandwidth at each resonant peak. The measured
 334 f_{res} and the measured fabricated resonator length were used
 335 to calculate the effective relative permittivity directly from the
 336 s-parameter measurements. The relative permittivity was

337 extracted from this data using the method and equations
 338 previously outlined in Section III. A plot of the measured $\epsilon_r(f)$
 339 for the Sheldahl and control substrates is given in Figs. 5–7.
 340 The results plotted here include the results of both the ring
 341 and quarter wave resonators. In the frequency band of 3 GHz
 342 to 18 GHz the $\epsilon_r(f)$ of the Sheldahl varies from 2.91 to 3.3
 343 (7% increase) with a mean value of 3.15. This compares with
 344 the manufacturer’s specification of 3.3 at 1 GHz. Additionally,
 345 the $\epsilon_r(f)$ of the substrate remains relatively constant across the
 346 entire frequency band, a desirable characteristic for broadband
 347 design. In comparison to the control substrates there is greater
 348 variation in the Sheldahl results. This is attributable to man-
 349 ufacturing variations in the resonators since the difficulty of
 350 handling the flexible substrate in the laboratory level photo-
 351 patterning facilities used for this paper lead to a higher
 352 variability in resonator dimensions than for the rigid substrates.
 353 Aside from using commercial flex patterning, a facility which
 354 was not available for this paper, a possible solution would
 355 be to significantly increase the number of flex test samples
 356 (from the 14 used in this paper) and to use averaging to
 357 compensate for the manufacturing variations. For the Taconic

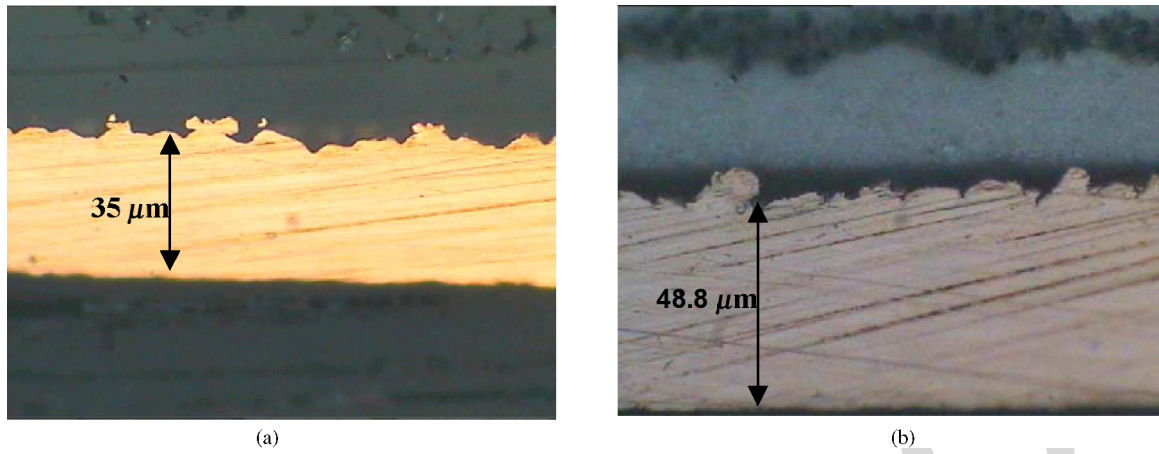


Fig. 8. Cross sections of the copper conductors fabricated on (a) FR4 and (b) CER10 at 500× magnification.

358 substrate the $\epsilon_r(f)$ increases from 9.14 to 10.55 (15.43%
 359 increase) while the $\epsilon_r(f)$ of the FR4 increases from 4.08 to 5.14
 360 (25.9% increase) across the measurement bandwidth. A further
 361 observation is the comparison of results between resonators
 362 fabricated with the same resonant frequencies. In the case of
 363 the flexible substrate, the largest difference observed between
 364 resonators occurs at 10 GHz, where the difference in ϵ_r is
 365 $\sim 8.3\%$. Therefore, either the ring or quarter wave resonant
 366 method yields the same results within an acceptable degree of
 367 measurement error. From a fabrication perspective, this is an
 368 important result as the quarter wave resonators are easier to
 369 fabricate and do not require the use of gap coupling to excite
 370 the resonator.

371 B. Conductor Loss

372 The conductor loss (α_c) for each microstrip structure was
 373 approximated using empirical equations reported by Collin
 374 [14]. These equations, which include loss due to surface
 375 roughness, have a reported accuracy of 6%–8%. Equations
 376 presented by Pucel [12], [13] were also evaluated but the
 377 predicted conductor loss for the microstrips on the flexible
 378 substrate was much higher and did not reflect the experimental
 379 results. The post fabrication dimensions, both magnified cross-
 380 sections and a profile measurement of the conductors were
 381 used to determine the surface roughness and improve the
 382 overall approximation of α_c . All conductors were fabricated
 383 of copper ($\sigma_{\text{ideal}} = 5.8 \times 10^7 \text{ S/m}$) and no solder mask or finish
 384 was applied. Photographs of the cross section for the rigid
 385 substrates are shown in Figs. 8 and 9.

386 The average surface roughness for the copper on flex was
 387 $\sim 1 \mu\text{m}$, while it was $\sim 5 \mu\text{m}$ for copper on the rigid substrates.
 388 The effect of this surface roughness was included in the
 389 calculation of conductor loss using a multiplication factor
 390 determined by [17]

$$\alpha_c = \alpha'_c \left\{ 1 + \frac{2}{\pi} \tan^{-1} \left[1.4 \left(\frac{\Delta}{\delta_s} \right)^2 \right] \right\} \quad (12)$$

391 where δ_s is the skin depth, Δ is the measured surface rough-
 392 ness, and α'_c is the calculated conductor attenuation without
 393 surface roughness included.

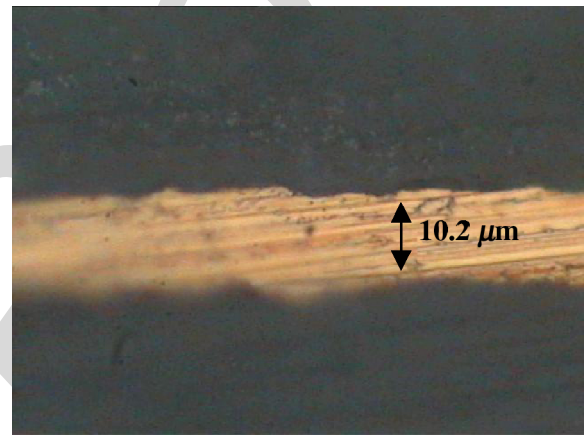


Fig. 9. Cross section of copper conductor on Sheldahl at 1000× magnification.

394 A plot of the calculated multiplication factors for specific
 395 levels of surface roughness is given in Fig. 10. A plot of
 396 the calculated conductor loss in dB/m for the microstrip
 397 structures on each substrate is shown in Fig. 11; from the
 398 plot it can be seen that the microstrip line on the flex exhibits
 399 the highest conductor loss per unit length. This is caused by
 400 the necessarily narrower line dimensions required to obtain
 401 any given line impedance on the thin flex when compared to
 402 the wider microstrip lines fabricated on the thicker control
 403 substrates.

404 C. Loss Tangent

405 Subtracting the calculated conductor and radiation loss from
 406 the measured total loss yields the loss attributable to the
 407 dielectric only. Radiation losses were determined for the open-
 408 ended quarter wave resonator using equations presented by
 409 Lewin [26] and Van der Pauw [19] but on all substrates it can
 410 be considered negligible (1.29 dB/m at 18 GHz on Sheldahl)
 411 when compared to conductor and dielectric losses.

412 The loss tangent is extracted from dielectric loss using
 413 (6), as previously outlined in Section II. The extracted loss
 414 tangent results for each test substrate are plotted across the
 415 measured frequency band in Figs. 12–14. The loss tangent of

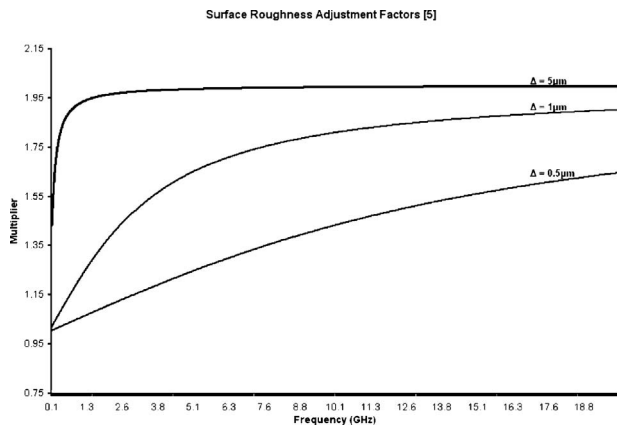


Fig. 10. Multiplier factor for the increase in conductor loss due to different surface roughness.

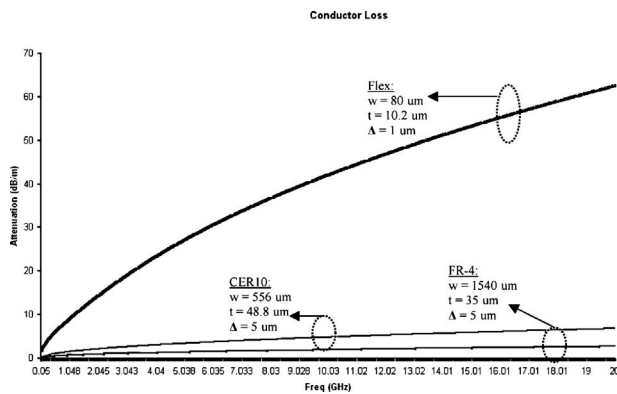


Fig. 11. Calculated conductor loss (dB/m) for each microstrip line using design equations presented by Collin [17].

416 the Sheldahl material ranges from 0.0078 at 3 GHz to 0.008
 417 at 18 GHz and can be considered constant with frequency
 418 with an average value of 0.00683. This result is lower than
 419 the manufacturer specified value of 0.011. The difference
 420 between manufacturer specifications and the extracted values
 421 is attributed to the very high conductor loss relative to die-
 422 lectric loss and the resultant increased difficulty in isolating
 423 the dielectric loss. Also included in the plot is the calculated
 424 loss tangent under 85/85 RH. Under these conditions the loss
 425 tangent increases to 0.0091 at 3 GHz but a decrease to 0.006
 426 is seen at 18 GHz with an average value of 0.0077. The FR4
 427 substrate has a measured loss tangent that ranges from 0.018
 428 at 2.5 GHz to 0.044 at 16.5 GHz, these values compare well to
 429 results previously published by Heinola [9] for an FR4-type
 430 substrate. The results also show that the exposure to 85/85
 431 RH conditions for a period of 48 h has no noticeable effect
 432 on the FR4 substrate. There are two reasons why the FR4
 433 did not exhibit a large variation in material properties after
 434 exposure to the 85/85 RH conditions. The first is attributed to
 435 the short soak time applied to the FR4 samples, the second
 436 reason is the presence of the copper ground plane which acts
 437 as a barrier to moisture diffusion [27]. In previously published
 438 results for the material properties of FR4, the specified soak
 439 times at which FR4 reaches saturation are taken as 200–400 h
 440 [28] depending on glass/resin content. For the purposes of
 441 this experiment and in light of the previously published data

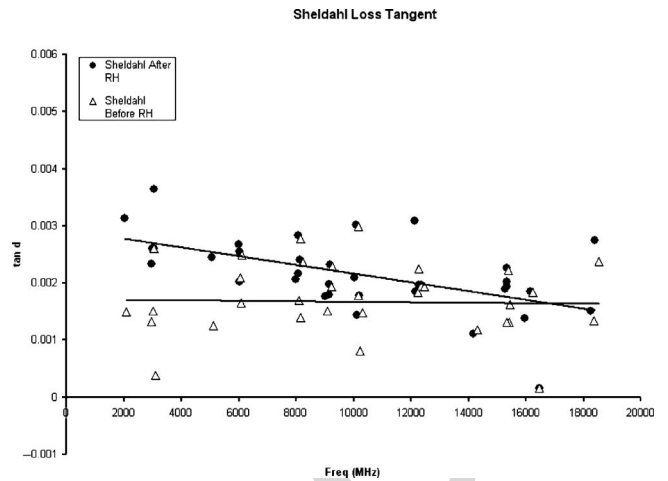


Fig. 12. Calculated loss tangent of Sheldahl substrate before and after RH exposure.

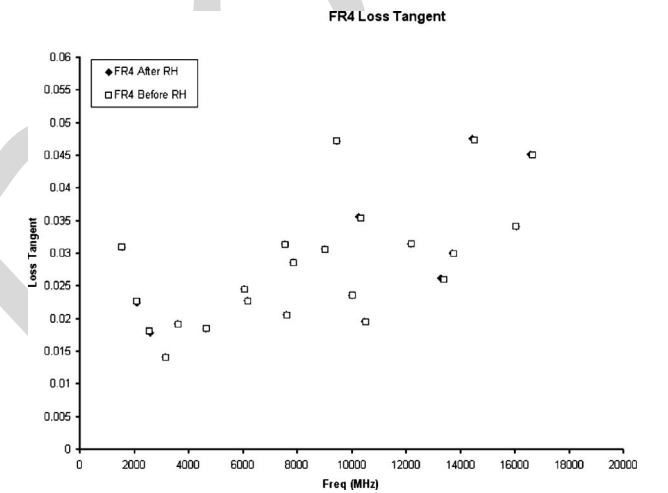


Fig. 13. Calculated loss tangent of FR-4 substrate before and after RH.

442 on FR4, the FR4 samples were only exposed to a soak time
 443 comparable with the soak time of the flexible substrate. A
 444 similar approach was taken with the CER10 samples. The
 445 manufacturer’s datasheet for the CER10 substrate specifies
 446 excellent resistance to moisture absorption and this is verified
 447 by the experimental results.

448 The CER10 exhibits the lowest loss tangent values, ranging
 449 from 0.0034 at 2 GHz to 0.0047 at 18 GHz. As expected,
 450 this is an order of magnitude smaller than the other two
 451 substrates. After exposure to 85/85 RH conditions the variation
 452 in calculated loss tangent is within measurement variation.
 453 Therefore the differences in pre-humidity and post-humidity
 454 are attributed to noise in the s-parameter measurements and
 455 not due to moisture absorption.

456 *D. Analysis of Flexible Substrate After RH Exposure*

457 A precision weighing scales was used to determine the mass
 458 of the Sheldahl sample pre and post RH exposure. The mass
 459 of the sample pre RH exposure was measured as 1.03195 g,
 460 the post RH sample was measured as 1.03490 g. There was an
 461 increase of 2.95 mg in mass due to water absorption, giving a

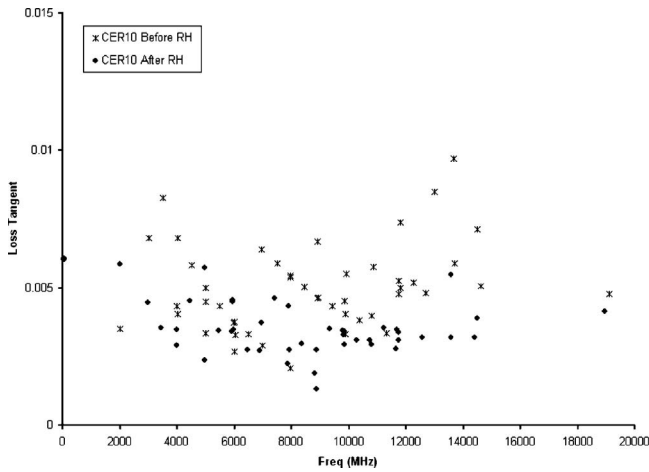


Fig. 14. Calculated loss tangent of CER-10 substrate before and after RH.

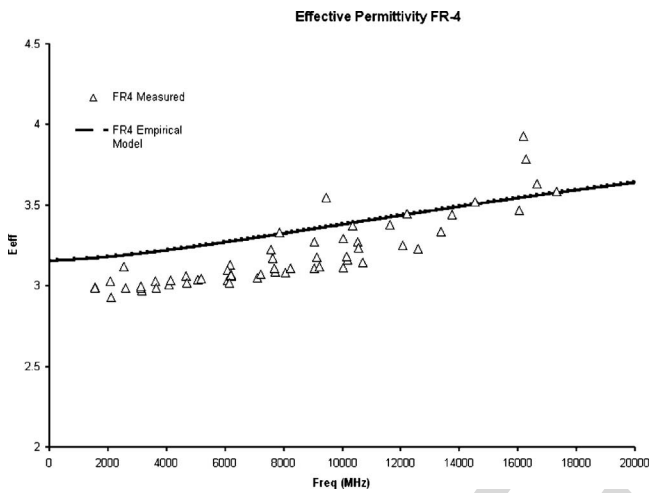


Fig. 15. Comparison of measured effective permittivity for FR4 to Kobayshi empirical equations [15].

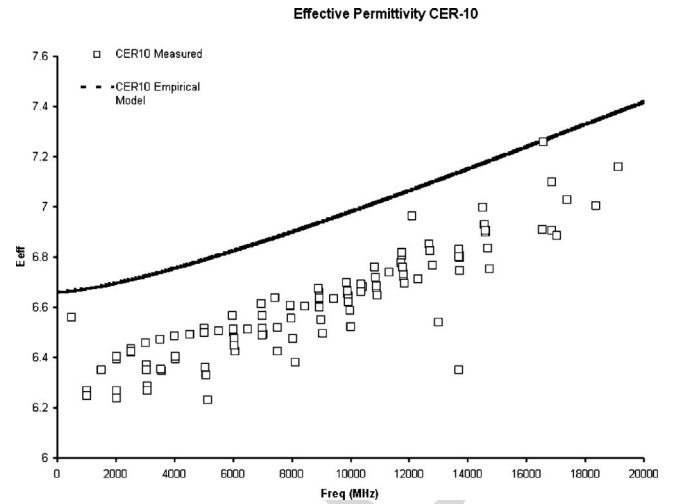


Fig. 16. Comparison of measured effective permittivity for CER10 to Kobayshi empirical equations [15].

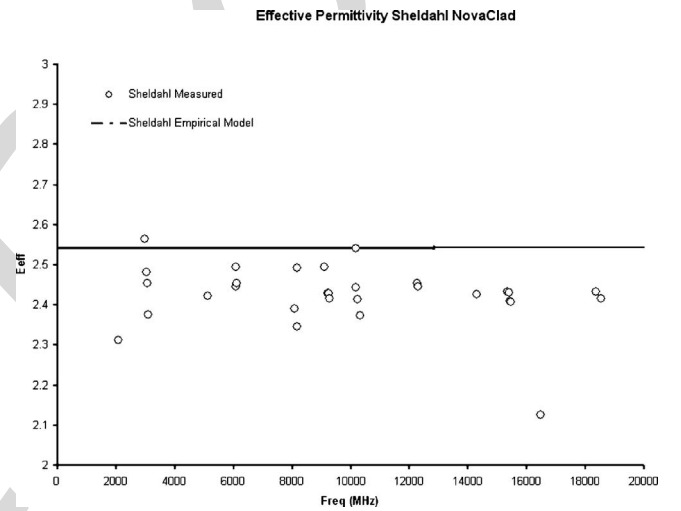


Fig. 17. Comparison of measured effective permittivity for Sheldahl NovaClad to Kobayshi empirical equations [15].

E. Comparison of Empirical Equations for the Prediction of ϵ_{eff}

A comparison of three of the reportedly [18] most accurate empirical equations for dielectric constant, Edwards [17], Kirchning [16], and Kobayshi [15] was also included in this paper. The static effective permittivity, $\epsilon_{\text{eff}}(0)$, was calculated using two methods: the first was to extrapolate the measured effective permittivity data to a zero frequency point; the second used further empirical equations with the manufacturers' specifications to calculate a static effective permittivity value. The best results were observed when using an extrapolated value for the $\epsilon_{\text{eff}}(0)$ and the Kobayshi equations. A comparison of the Kobayshi model calculated using an empirically derived static effective permittivity to the measured values is plotted in Figs. 15–17. The empirical model, calculated using an extrapolated value for the static effective permittivity shows better correlation to the measured effective permittivity for all substrates. This is shown in Fig. 18. Using this approach could allow the approximation of effective permittivity outside

percentage moisture absorption ratio of 0.285%. At saturation, a polyimide sample typically has a moisture absorption ratio of 2% and the reduced moisture absorption here is attributed to the presence of a copper ground plane, which inhibits moisture diffusion. This reduced level of moisture absorption has been previously observed in organic laminate materials that have copper ground planes [27]. An increase in moisture content of $\sim 0.3\%$ would lead to an increase in capacitance between planes of 2.5%; considering the impedance of a microstrip line, this would lead to a decrease in characteristic impedance. Due to the presence of moisture, the average value of the experimentally determined loss tangent of the Sheldahl substrate has increased by approximately $\sim 13.3\%$ (increased from 0.0068 to 0.0077). The relative permittivity has increased by 5–10% after 85/85RH conditions, this increase in permittivity would cause a reduction in the propagation delay along an interconnect and also effect the characteristic impedance of the interconnect. Although the observed degree of moisture absorption was relatively small, it is clear that the sensitivity of transmission line electrical parameters to changes in loss tangent and dielectric constant can result in large variations of those parameters.

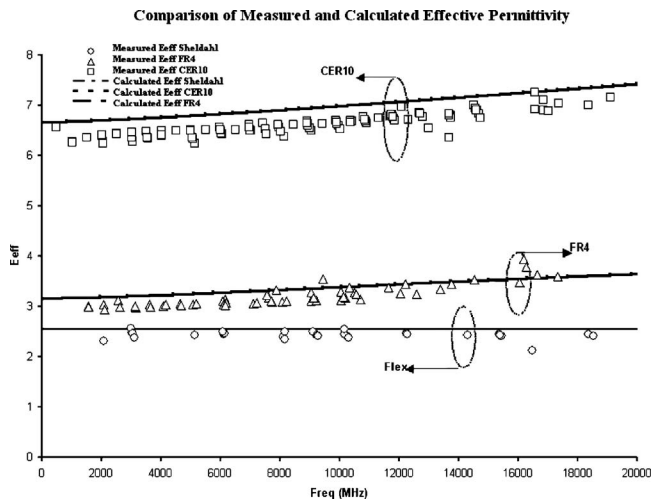


Fig. 18. Comparison of measured effective permittivity to Kobayshi empirical equation using a static effective permittivity extrapolated from measured data.

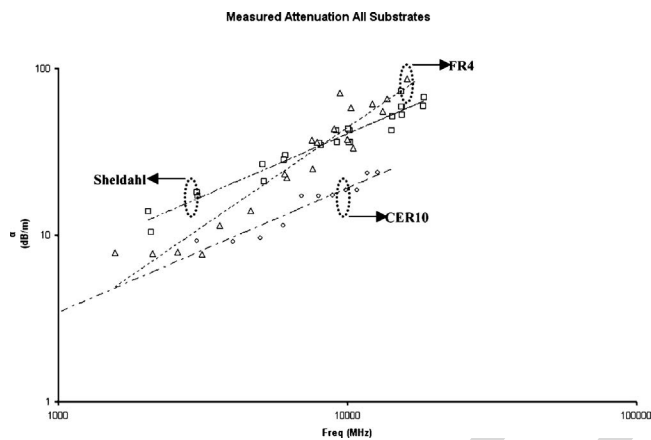


Fig. 19. Measured attenuation (dB/m) for each of the substrates.

503 the range of this paper. Although the calculations involved
 504 are relatively straightforward, it was noted that the equations
 505 presented by Edwards give a very good approximation and can
 506 easily be performed by hand.

507 *F. Benchmarking Against Control Substrates*

508 The loss tangent is one of the main metrics used to bench-
 509 mark a high frequency substrate; the desirable qualities of a
 510 high frequency substrate are a consistent relative permittivity
 511 with frequency and a low loss tangent. Inspecting Figs. 12–14,
 512 the substrate with the lowest loss tangent is the Taconic CER-
 513 10 while both the FR4 and flexible substrate have comparable
 514 loss tangents. This analysis alone is not sufficient when
 515 comparing the high frequency performance of the substrates as
 516 the conductor loss that dominates the Sheldahl total loss must
 517 also be included. The measured total attenuation per meter for
 518 each substrate is plotted on a log-log scale in Fig. 19.

519 The use of a log-log scale is useful in determining the
 520 dominant loss mechanism [29], on this scale a slope of 0.5 is
 521 conductor loss while a slope equal to 1 characterizes dielectric
 522 losses. From the plot, both the Sheldahl and CER10 attenua-
 523 tion is dominated by conductor loss (slopes ≈ 0.7). In the

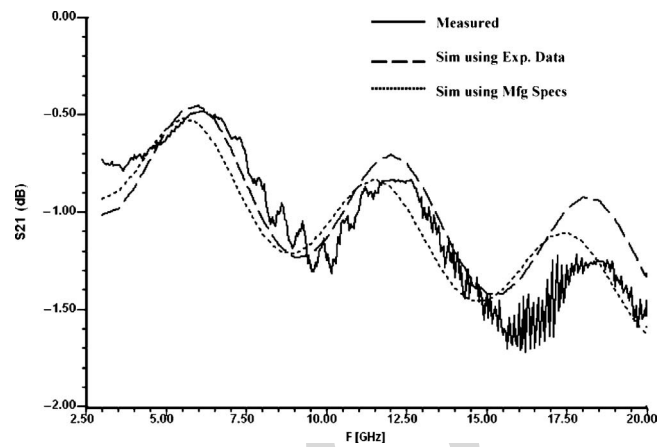


Fig. 20. Simulated and measured S21 (dB) for a 16 mm long microstrip line on flex.

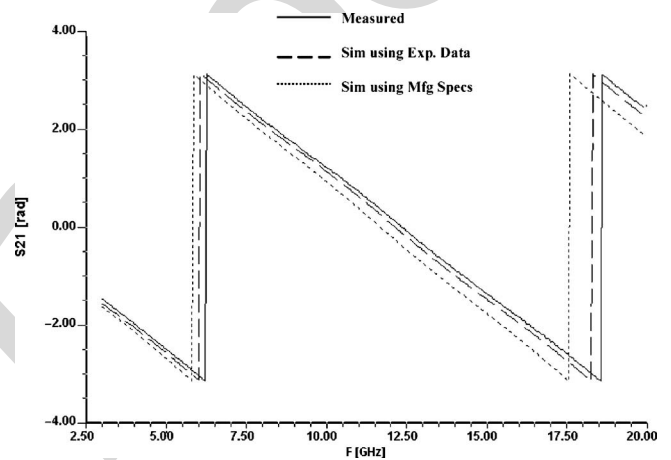


Fig. 21. Simulated and measured S21 (radians) for a 16 mm long microstrip line on flex.

524 case of the Sheldahl this is due to the narrow conductor, while
 525 for the CER10 this is due to the low dielectric loss compared
 526 to dielectric loss. The FR4 is dominated by dielectric loss
 527 (slopes ≈ 1). Therefore, it can be concluded that microstrip
 528 transmission lines with characteristic impedances in the region
 529 of $40\Omega - 60\Omega$ on a Sheldahl substrate of $48\mu\text{m}$ will exhibit
 530 the highest loss up to 10 GHz. In comparison to the least lossy
 531 substrate (CER10) substrate, the flexible substrate exhibits
 532 twice the attenuation per unit length.

533 *G. Validation*

534 To evaluate the influence of using the measured data on
 535 simulation results, EM and RF circuit simulations of mi-
 536 crostrip lines were performed. Microstrip lines of the same
 537 cross section but with varying lengths were fabricated with
 538 the resonator structure test coupons. S-parameter measure-
 539 ments were taken for each microstrip line over a 1 GHz to
 540 20 GHz bandwidth. The geometry of the microstrip lines were
 541 used with the manufacturer’s material specifications and the
 542 measured material properties to create microstrip models. One
 543 such model was generated and simulated using a commercial
 544 field solver (Sonnet EM [30]). The simulation was repeated
 545 twice, firstly using the average extracted frequency dependent

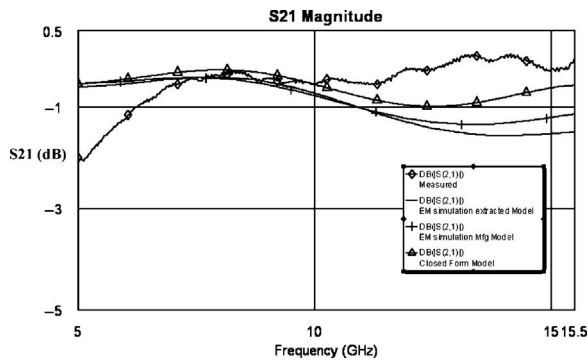


Fig. 22. S21 (dB) results from EM and circuit simulation of a 9.96 mm microstrip line on FR4 using manufacturer and measured material properties.

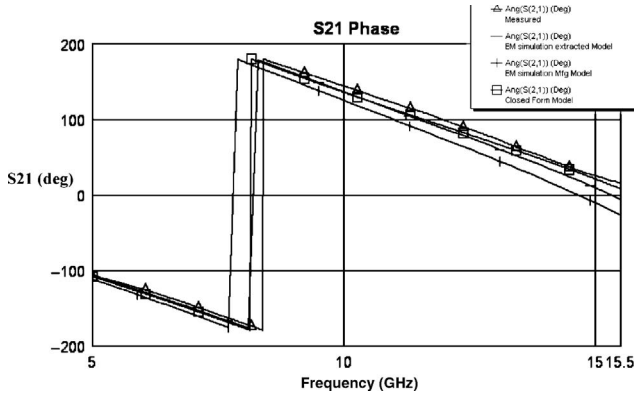


Fig. 23. S21 (deg) results from EM and circuit simulation of a 9.96 mm microstrip line on FR4 using manufacturer and measured material properties.

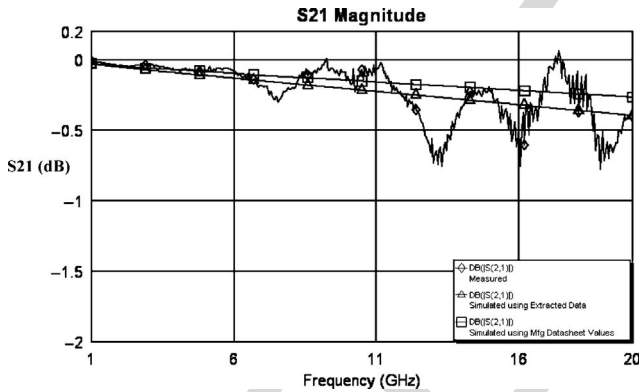


Fig. 24. S21 (dB) results from EM and circuit simulation of a 12 mm microstrip line on CER10 using manufacturer and measured material properties.

546 material (in the case of microstrip on Sheldahl: $\tan \delta = 0.0068$
 547 and $\epsilon_r = 3.015$). To include the effects of conductor surface
 548 roughness the conductor conductivity that was adjusted. This
 549 “effective” conductivity, $\sigma_{\text{effective}}$, was calculated using an
 550 equation presented in [31] and given in

$$\sigma_{\text{effective}} = \left(\frac{\sigma_{\text{ideal}}}{(1 + e^{-(\delta/\Delta)^{1.6}})^2} \right) \quad (13)$$

551 where δ is the skin depth in μm and Δ is the surface roughness
 552 in μm .

553 The second simulation set-up used the static properties
 554 specified by the manufacturer datasheets ($\tan \delta = 0.011$ and

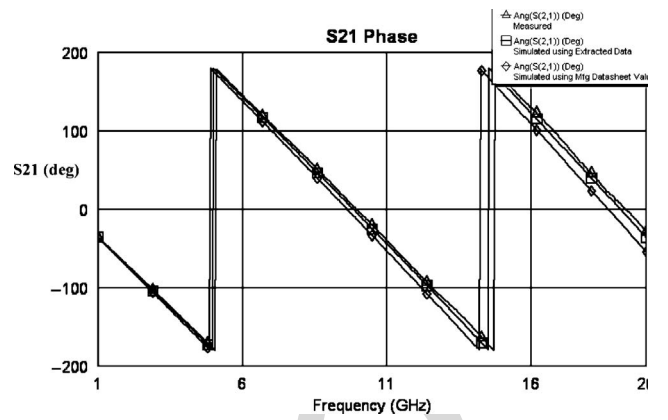


Fig. 25. S21 (deg) results from EM and circuit simulation of a 12 mm microstrip line on CER10 using manufacturer and measured material properties.

555 $\epsilon_r = 3.3$) and ideal conductor properties. The s-parameter
 556 results of the simulations were compared in order to high-
 557 light the correlation between the predicted and measured
 558 s-parameters. In particular, a comparison was made between
 559 the magnitude and phase of the S21 parameter. This parameter
 560 was chosen as the both the loss (effected by $\tan \delta$ and
 561 conductor conductivity) and propagation delay (effected by
 562 relative permittivity) is captured by this parameter. Figs. 20
 563 and 21 plot the simulated and measured S21 results for a
 564 16.07 mm long microstrip line with a line width of $59.67 \mu\text{m}$
 565 fabricated on the Sheldahl substrate. By inspection of the plots
 566 it is seen that using the experimentally determined value for
 567 the relative permittivity gives a better prediction of the phase
 568 than using the manufacturer’s value. In the case of the magni-
 569 tude of S21, the experimentally determined loss tangent also
 570 gives a better prediction in the frequency range 4 GHz to
 571 15 GHz. Outside of this range both simulation results begin
 572 to diverge from the measured result.

573 This type of simulation was also repeated for microstrip
 574 lines fabricated on both the FR4 and CER10 substrates.
 575 Average values for the substrate material properties were taken
 576 at the frequencies defined by manufacturers data. The results
 577 for the FR4 simulation of a 9.96 mm microstrip line are given
 578 in Figs. 22 and 23. Additionally, an RF circuit simulator was
 579 used to simulate a microstrip models that are defined by the
 580 manufacturers and measured material properties. The results
 581 of these simulations for a microstrip line fabricated on FR4
 582 and CER10 are given in Figs. 22–25. As in the case of the EM
 583 simulation results the s-parameter response of the microstrip
 584 models defined by the measured material properties more
 585 closely match the measured results. From these results it can
 586 be seen that the measured relative permittivity and loss tangent
 587 values can be used to better model the actual as manufactured
 588 microstrip line than using manufacturer specifications.

589 VIII. DISCUSSION AND CONCLUSION

590 An investigation into the high frequency electrical prop-
 591 erties of interconnects fabricated on a Sheldahl NovaClad
 592 substrate has been presented. The $\epsilon_r(f)$, $\epsilon_{\text{eff}}(f)$, $\tan \delta$, conductor
 593 losses and total loss have been determined under ambient
 594 RH conditions and under 85/85 RH conditions. The flexible

substrate has an $\epsilon_r(f)$ and $\tan\delta$, which varies from 2.91 to 3.119 and 0.0078 to 0.008 over the measured bandwidth. There is variation in the extraction of the loss tangent values from the measurements; this is attributed to the dependency of the resonator approach on the estimation of conductor losses. It has also been observed that the difference between resonator methods is negligible in terms of determining the relative permittivity. Since the quarter wave resonator does not require coupling gaps and has dimensions that are easier to control during fabrication this is the recommended approach for determining the material properties of similar flexible substrates. Additionally, it has been found that empirical equations presented by Kobayashi give the best approximation of the effective permittivity across the measured bandwidth. The saturation of the flexible substrate did not obey Ficke's law due to the presence of the copper ground plane, inhibiting moisture diffusion. Therefore, the degree of moisture diffusion will vary from application to application depending on the flexible PCB stack up and metallization. Finally, the comparison of the flexible substrate to the control substrates showed that when used to as the carrier substrate for typical microstrip line structures it would exhibit the largest loss per unit length due to higher conductor losses. The validation of the extracted material properties shows an improvement in the prediction of the magnitude and phase of the s-parameters of a microstrip on a flexible substrate and on the control substrates when using experimentally extracted material properties and the concept of an effective conductivity in place of the manufacturer's datasheet values.

ACKNOWLEDGMENT

The authors would like to acknowledge the support of the Tyndall National Institute, Cork, Ireland.

REFERENCES

- [1] B. McDermott and S. McKinney, "Dielectric material properties: Essential inputs to an accurate signal-integrity analysis and high-reliability design," in *Proc. DesignCon*, 2006.
- [2] D. Leys, "Best materials for 3–6 GHz design," *Printed Circuit Design Manuf. Mag.*, pp. 34–39, Nov. 2004.
- [3] B. O'Flynn, J. Buckley, D. Laffey, J. Barton, and S. C. O'Mathuna, "Simulation, design, development and test of antennas for wireless sensor network systems," *Microelectron. Int.*, vol. 24, no. 2, pp. 3–6, 2007.
- [4] M. S. Doyle, W. Martin, D. Pease, and T. Timpane, "Low-loss flex circuit interconnect: Development of reduced insertion-loss flexible packaging," in *Proc. 57th ECTC*, 2007, pp. 1870–1876.
- [5] H. Braunisch, J. E. Jaussi, J. A. Mix, M. B. Trobough, B. D. Horine, V. Prokofiev, L. Daoqiang, R. Baskaran, P. C. H. Meier, H. Dong-Ho, K. E. Mallory, and M. W. Leddige, "High-speed flex-circuit chip-to-chip interconnects," *IEEE Trans. Adv. Packag.*, vol. 31, no. 1, pp. 82–90, Feb. 2008.
- [6] K. C. Chang, *Microstrip Ring Circuits and Related Structures*. New York: Wiley, 2004.
- [7] G. Zhou and H. Gronqvist, "Characterization of liquid crystal polymer for high frequency system-in-a-package applications," *IEEE Trans. Adv. Packag.*, vol. 25, no. 4, pp. 503–508, Nov. 2002.
- [8] J. Heinola, "A method to evaluate effects of moisture absorption on dielectric constant and dissipation factor of printed circuit board materials," in *Proc. 9th Int. Symp. Adv. Packag. Mater. Processes, Properties Interfaces*, 2004, pp. 241–246.

- [9] K.-P. Latti, J.-M. Heinola, M. Kettunen, J.-P. Strom, and P. Silventoinen, "A review of microstrip t-resonator method in determination of dielectric properties of printed circuit board materials," in *Proc. IEEE IMTC*, May 2005, pp. 62–66.
- [10] *Sheldahl NovaClad Technical Information* [Online]. Available: <http://www.sheldahl.com/Product/bulletins/g2300.pdf>
- [11] *CER10 Datasheet* [Online]. Available: <http://www.taconic-add.com/pdf/cer10.pdf>
- [12] R. A. Pucel, D. J. Masse, and C. P. Hartwig, "Losses in microstrip," *IEEE Trans. Microw. Theory Tech.*, vol. MTT-16, no. 6, pp. 342–350, Jun. 1968.
- [13] R. A. Pucel, D. J. Masse, and C. P. Hartwig, "Correction to losses in microstrip (correspondence)," *IEEE Trans. Microw. Theory Tech.*, vol. 16, no. 12, p. 1064, Dec. 1968.
- [14] R. E. Collin, *Foundations for Microwave Engineering*, 2nd ed. New York: Wiley-IEEE, 2000.
- [15] M. Kobayashi, "A dispersion formula satisfying recent requirements in microstrip CAD," *IEEE Trans. Microw. Theory Tech.*, vol. 36, no. 8, pp. 1246–1250, Aug. 1988.
- [16] M. Kirsching and R. H. Jansen, "Accurate model for effective dielectric constant of microstrip with validity up to millimeter wave frequencies," *Electron. Lett.*, vol. 18, no. 6, pp. 272–273, Mar. 1982.
- [17] T. C. Edwards and M. B. Steer, *Foundations of Interconnect and Microstrip Design*. Norwood, MA: Artech House, 2001.
- [18] R. A. York and R. C. Compton, "Experimental evaluation of existing CAD models for microstrip dispersion," *IEEE Trans. Microw. Theory Tech.*, vol. 38, no. 3, pp. 327–328, Mar. 1990.
- [19] L. J. van der Pauw, "The radiation of electromagnetic power by microstrip configurations," *IEEE Trans. Microw. Theory Tech.*, vol. 25, no. 9, pp. 719–725, Sep. 1977.
- [20] Y. Shimamura, T. Urabe, A. Todoroki, and H. Kobayashi, "Measurement of moisture absorption ratio of FRP using micro polymer sensor," *Key Eng. Mater.*, vols. 270–273, pp. 1957–1964, Aug. 2004.
- [21] J. Carroll, M. Li, and K. Chang, "New technique to measure transmission line attenuation," *IEEE Trans. Microw. Theory Tech.*, vol. 43, no. 1, pp. 219–222, Jan. 1995.
- [22] Layout rules for GHz probing. *Cascade MicroTech Application Note* [Online]. Available: www.cmicro.com
- [23] D. Williams and T. Miers, "A coplanar probe to microstrip transition," *IEEE Trans. Microw. Theory Tech.*, vol. 36, no. 7, pp. 1219–1223, Jul. 1988.
- [24] G. Zheng, J. Papapolymerou, and M. M. Tentzeris, "Wideband coplanar waveguide RF probe pad to microstrip transitions without via-holes," *IEEE Microw. Wirel. Compon. Lett.*, vol. 13, no. 12, pp. 544–546, Dec. 2003.
- [25] Microwave Office [Online]. Available: <http://web.awrcorp.com>
- [26] L. Lewin, "Spurious radiation from microstrip," *Proc. IEEE*, vol. 125, no. 7, pp. 633–642, 1978.
- [27] M. G. Pecht, H. Ardebili, A. A. Shukla, J. K. Hagge, and D. Jennings, "Moisture ingress into organic laminates," *IEEE Trans. Compon. Packag. Technol.*, vol. 22, no. 1, pp. 104–110, Mar. 1999.
- [28] S. Khan, "Comparison of the dielectric constant and dissipation factors of non-woven aramid/FR4 and Glass/FR4 laminates," Dupont Advanced Fibers Systems Division, *Tech. Note*.
- [29] A. Byers, "Accounting for high frequency transmission line loss effects in HFSS," in *Proc. Ansoft User Workshop*, 2003 [Online]. Available: <http://www.ansoft.com>
- [30] Sonnet EM Software [Online]. Available: www.sonnetusa.com
- [31] CST Microwave Studio [Online]. Available: www.cst.com



Eoin McGibney received the Ph.D. degree in electronic engineering from the Cork Institute of Technology, Bishopstown, Cork, Ireland, in 2009.

His research focused on the measurement and modeling of IC packaging and materials for high frequency applications. Since 2006, he has been a Test Development Engineer with the Digital Video Product Group, Analog Devices, Limerick, Ireland. His current research interests include the field of design for test for mixed signal ICs.

723
724
725
726
727
728
729
730
731
732
733
734
735



John Barrett is the Head of Academic Studies with the Nimbus Center for Embedded Systems Research, Cork Institute of Technology (CIT), Bishopstown, Cork, Ireland, and is the Group Director of the Center's Smart Systems Integration Research Group. He has been a Lecturer and Researcher with CIT since 1999, and was previously an Assistant Director of the Irish National Microelectronics Research Center (now Tyndall National Institute), Cork. His current research interests include packaging, miniaturization, and embedding of smart systems in materials, objects, and structures with particular emphasis on challenging and harsh application environments.



John Barton received the M.Eng.Sc. degree from University College Cork, Cork, Ireland, in 2006. He joined the Interconnection and Packaging Group, National Microelectronics Research Center (now Tyndall National Institute), Cork, as a Research Engineer in 1993. Currently, he is with the Wireless Sensor Networks Team where his current research interests include ambient systems research, wearable computing, high density flexible interconnect, wireless sensor networks, and materials research for 3-D packaging. As PI on the Enterprise Ireland Funded D-Systems Project, he has been the leader of the development of the Tyndall Wireless Sensor Mote Platform. He has authored or co-authored over 90 peer-reviewed papers.

736
737
738
739
740
741
742
743
744
745
746
747
748
749

AQ:6

IEEE PROOF

AUTHOR QUERIES

AUTHOR PLEASE ANSWER ALL QUERIES

- 750
751 AQ:1= Please provide affiliation lines and biographies of authors “Liam Floyd, Paul Tassie.”
752 AQ:2= Please provide page range in Ref. [1].
753 AQ:3= Please provide vol. no. in Ref. [2].
754 AQ:4= Please provide month in Ref. [26].
755 AQ:5= Please update Ref. [28].
756 AQ:6= Please provide the expanded form of “PI.”
- 757 END OF ALL QUERIES

IEEE Proof